

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	112857	electrode same etch\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:31
L2	2	1 same ((focused near ion near beam or "FIB") same (metal near mask\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:51
L3	5	1 and ((focused near ion near beam or "FIB") same (metal near mask\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:43
L4	2767	electrode same (nano or nanometer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:44
L5	7	4 same (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:50
L6	58653	(etch\$3 or pattern\$3) same ((electrode near layer) or gold or "Au")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:51
L7	14201	6 same mask\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:51
L8	36	7 same (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 19:52
L9	29	8 and @pd<"20030214"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:23

L10	2	(nano near gap near electrode) same (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:23
L11	21	nagase-takashi.in.	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:26
L12	53	kubota-tohru.in.	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:26
L13	1	12 and (focused near ion near beam or "FIB")	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:55
L14	1	12 and (nano near gap near electrode)	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:27
L15	1	mashiko-shinro.in. and (focused near ion near beam or "FIB")	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:35
L16	1756	electrode same (metal near mask\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:37
L17	14	16 and (nanometer or nano)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:37
L18	13	16 and (focused near ion near beam or "FIB")	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:56
L19	6	18 and (nano or nanometer)	US-PGPUB; USPAT	OR	OFF	2005/06/02 20:57
L20	46125	(etch\$3 or pattern\$3) same (gold or "Au")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:58
L21	447	20 same (mask\$3 near metal)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 20:59
L22	116	21 and (nanometer or "nm" or nano)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:19
L23	1	22 and (mask\$3 same (focused near ion near beam or "FIB"))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:17

L24	58126	etch\$3 same (mask\$3 near layer or metal near mask\$3 or titanium or "Ti")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:17
L25	496	24 and (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:06
L26	147	25 and 20	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:18
L27	99	26 and (nanometer or "nm" or nano)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:19
L28	56	27 and @pd<"20030214"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:41
L29	9053	((etch\$3 or pattern\$3) same (open\$3 or hole)) same (nanometer or "nm" or nano)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:42
L30	3272	29 same mask\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:43
L31	70	29 same (metal near mask\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:43
L32	30	31 and @pd<"20030214"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:51
L33	151	nano near lithograph\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:52

L34	21	33 and (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 21:53
L35	21	34 and (nanometer or "nm" or nano)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:05
L36	48884	(open\$3 or gap or aperture or hole) same (nanometer or "nm")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:06
L37	7255	36 same etch\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:06
L38	2739	37 same mask\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:06
L39	86	38 and (focused near ion near beam or "FIB")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/02 22:07